

Application No.	Applicant(s)	
10/092,890	LUTZ, MARKUS	
Examiner	Art Unit	
Victor V Yevsikov	2825	

SEARCHED				
Class	Subclass	Date	Examiner	
438	107, 53, 50, 33, 113	2/19/2004	VY	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
Same a	s above	2/19/2004	VY	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
pack and laser and cap and wafer and (melt or molten) and (cap with (melt or molten) with laser	2/19/2004	VY
MEMS or (microelectromechanical adj system)) and laser with (absorption or transperent)) and (cap with melt	2/19/2004	VY